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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of )  
Shunpei YAMAZAKI et al. )  
Serial No. 08/841,644 )  
Filed: April 30, 1997 )  
For: SEMICONDUCTOR DEVICE )  
AND METHOD FOR FORMING )  
THE SAME )

Art Unit: 2813  
Examiner: C. Bowers, Jr.

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CERTIFICATE OF MAILING

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*Jose M. Fichtel*

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
Washington, DC 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, Applicant submits herewith attached Form PTO-1449 listing a reference known to Applicant and requests that this reference be made of record in the above identified application. A copy of the reference listed is submitted herewith in accordance with 37 C.F.R. 1.98(a). It is requested that the accompanying information disclosure statement be considered and made of record in the above-captioned application. To assist the Examiner, the document is listed on the attached form PTO-1449. It is respectfully requested that the Examiner initial a copy of this form and return to the undersigned.

A check in the amount of \$180 is being submitted to comply with the provisions of 37 C.F.R. § 1.97(d)

Respectfully submitted,

*[Signature]*

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